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Atty. Dkt. No. AMAT/5730/TCG/WCVD/LE

PATENT

03 CO #13

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yoo, et al.

Serial No.: 10/023,125

Filed: December 17, 2001

For: Pulse Nucleation Enhanced
Nucleation Technique For
Improved Step Coverage
And Better Gap Fill For
WCVD Process

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Group Art Unit: Unknown

Examiner: Unknown

Confirmation No.: 5485

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

CERTIFICATE OF MAILING	
37 CFR 1.8	
I hereby certify that this correspondence is being deposited on	
<u>1/7</u>	2003 with the United States Postal Service
as First Class Mail in an envelope addressed to:	
Commissioner for Patents, Washington, D.C. 20231.	
<u>1/7/03</u>	<u>B. Todd Patterson</u>
Date	Signature

STATUS INQUIRY

More than twelve months have passed since the filing of this application on December 17, 2001.

No communication (including Filing Receipt) has been received from the Patent and Trademark Office indicating action on this application.

Kindly advise the undersigned of the present status of this application.

Respectfully submitted,

B. Todd Patterson

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